



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

ERKKI HEINONEN

Appln. No. 10/062,176

Filed: January 31, 2002

) Group Art Unit: 3761

) Examiner:

) LIQUID RESERVOIR FOR NEBULIZER

)

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INFORMATION DISCLOSURE STATEMENT FEB 21 2003

Milwaukee, Wisconsin 53202  
February 12, 2003  
TECHNOLOGY CENTER R3700

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Attached is a copy of published PCT Patent Application WO 01/19437. This PCT document is based on U.S. Patent Application 09/397,529 filed September 16, 1999, naming the same inventor as in the present application, Erkki Heinonen of Helsinki, Finland, as inventor and assigned to the same assignee as the present application, the Instrumentarium Corp. of Helsinki, Finland. The issue fee has been paid in the U.S. application and it is, at present, awaiting issuance.

The PCT application corresponding to the '529 application published March 16, 2001. The PCT application/'529 application shows a nebulizer of the type with which the liquid reservoir of the present invention may be utilized. It does not show an attached nebulizer reservoir which forms the subject matter of the present application.

Also attached are copies of published European Patent Applications 1,219,313 and 1,219,314. These published patent applications contain a generalized showing of an attached reservoir. These European applications published after the filing date of the present application.

Also attached is a PTO Form 1449, in duplicate, listing the attached.

Respectfully submitted,

ANDRUS, SCEALES, STARKE & SAWALL, LLP

*Daniel D. Fetterley*

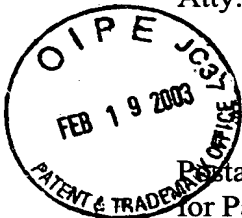
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ADDRESS AND CERTIFICATE OF MAILING ATTACHED

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Atty. Docket No. 2532-00277 (C.12105-78)



CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on the 12<sup>th</sup> day of February, 2003.

|                            |                |
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